



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. 09/942,856

Filed: August 29, 2001

For: METHODS FOR MANUFACTURING  
RETICLES FOR CHARGED-PARTICLE-BEAM  
MICROLITHOGRAPHY EXHIBITING  
REDUCED PROXIMITY EFFECTS, AND  
RETICLES PRODUCED USING SAME

Examiner: Unknown

Date: January 7, 2002

COPY OF PAPERS  
ORIGINALLY FILED

2878  
PATENT  
# 5<sup>ed</sup>  
BJ  
03-13-02

Art Unit: 2878

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on January 7, 2002 as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Donald L. Stephens Jr.  
Attorney for Applicant

INFORMATION DISCLOSURE STATEMENT  
PURSUANT TO 37 C.F.R. § 1.97(b)

COMMISSIONER FOR PATENTS  
WASHINGTON, DC 20231

Sir:

Listed on the accompanying form PTO-1449 and enclosed herewith is an English-language document. Applicant respectfully requests that this document (if it issues as a patent before the instant application) be listed as a reference cited on the issued patent.

Applicant filed this Information Disclosure Statement ("IDS") within three months of the filing date of a national application, within three months of the date of entry of the national stage as set forth in § 1.491 in an international application, before the mailing date of a first Office action on the merits, or before the mailing of a first Office action after the filing of request for continued examination under § 1.114. As a result, no fee should be required to file this IDS. However, if the Patent Office determines that a fee is required for Applicant to file this Information Disclosure Statement, please charge any such fees, or credit overpayment, to Deposit Account No. 02-4550. A **duplicate** copy of this Information Disclosure Statement is enclosed.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

By

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PATENT  
Attorney Reference Number 4641-59019

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In re application of: OKINO

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Attorney for Applicant

TRANSMITTAL LETTER

COMMISSIONER FOR PATENTS  
WASHINGTON, DC 20231

Enclosed for filing in the application referenced above are the following:

- Information Disclosure Statement
- Form 1449 and copy of reference cited thereon
- The Director is hereby authorized to charge any additional fees that may be required, or credit over-payment, to Account No. 02-4550. A copy of this sheet is enclosed.
- Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

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cc: Docketing